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Substitute for form 1449A/PTO  <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  <i>(use as many sheets as necessary)</i>				<b>Complete if Known</b>	
				Application Number	10/547,202
				Filing Date	10/11/2006
				First Named Inventor	David L. Dickensheets
				Group Art Unit	2873
				Examiner Name	Not Yet Assigned
Sheet	1	of	2	Attorney Docket Number	MONT-021/00US/306509-2055

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. <sup>1</sup>	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY
		Number	Kind Code <sup>2</sup> (if known)		
		5,907,425		Dickensheets, et al.	05/25/1999
		6,661,561		Fitzpatrick, et al.	12/09/2003
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		PCT/US2004/001896		Himmer, et al.	01/26/2004

FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY
		Office <sup>3</sup>	Number <sup>4</sup>	Kind Code <sup>5</sup> (if known)		
		WO	03/036737		Dickensheets, et al.	05/01/2003
		WO	2004/068180		Himmer, et al.	08/12/2004

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>1</sup> Unique citation designation number.

<sup>2</sup> See attached Kinds of U.S. Patent Documents.

<sup>3</sup> Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3).

<sup>4</sup> For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document.

<sup>5</sup> Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible.

<sup>6</sup> Applicant is to place a check mark here if English language Translation is attached.

OTHER – NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>1</sup>
		DAVID L. DICKENSHEETS and GORDON W. KINO, Silicon-Micromachined Scanning Confocal Optical Microscope, Journal of Microelectronmechanical Systems, Vol. 7, No. 1, March 1998, pp. 38-47. A Joint IEEE/ASME Publication	
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Examiner Signature		Date Considered	
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